



1765

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Nakamura et al.

Serial No.: 09/856,212

Filed: May 18, 2002

For: **PRODUCTION METHOD FOR SILICON
SINGLE CRYSTAL WAFER**

Examiner: Matthew J. Song

) Art Unit: 1765

) Confirmation No.: 9409

) *I hereby certify that this correspondence is
) being deposited with the United Postal
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) addressed to: Mail Stop NON-FEE
) AMENDMENT, Commissioner of Patents,
) P.O. Box 1450, Alexandria, VA, 22313-
) 1450, on*

) April 5, 2004

) *Gerald T. Shekleton*
) Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop NON-FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The office action of January 14, 2004 has been carefully reviewed and the following amendments and remarks are made in response thereto.

*Entered
N/RCE
dtd
5/14/04*